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Attorney Docket Number

(Use as many sheets as necessary) To Be Assigned **Examiner Name**

Sheet 1

Examiner Initials*	Cite No.1	Document Number Number-Kind Code ^{2 (# known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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 		^{US-} 5,653,894	08-05-1997	Ibbotson et al.		
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INFO	ORMATIO	N DIS	CLOSURE	Filing Date	August 20, 2003	
STA	TEMENT	BY A	PPLICANT	First Named Inventor	Banqiu Wu et al.	
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